

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen et al.	Group Art Unit: 1763
Application No: 09/595,778	Examiner: Allan W. Olsen
Confirmation No: 6490	
Filed: June 16, 2000	Attorney Docket No: 002077 USA D01/ETCH/SILICON/JB1
Title: APPARATUS AND METHOD FOR MONITORING PROCESSING OF A SUBSTRATE	October 18 th , 2006 San Francisco, California

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

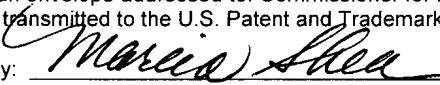
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Examiner Olsen:

This communication is in response to the Office communication mailed on May 18th, 2006 and is being filed with a petition for a two month extension of time.

Certificate of Transmission

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By: 
Marcia Shea

Date: October 18th, 2006